

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

JAE-SEOK JEONG *et al.*

Serial No.: *to be assigned*

Examiner: *to be assigned*

Filed: 25 February 2002

Art Unit: *to be assigned*

For: SUBSTRATE AND PLASMA DISPLAY PANEL UTILIZING THE SAME



**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner  
for Patents  
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. §1.56, and §§1.97 and 1.98 as amended, Applicant cites, provides copies of, and discusses the following art reference:

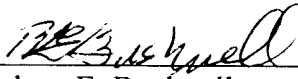
- ▶ U.S. Patent No. 5,967,872 to Betsui *et al.* discloses *Method for Fabrication of a Plasma Display Panel*.

The foregoing citation of references is not intended to constitute an assertion of particular relevant and is not intended to constitute a search that applicant has undertaken a through search of the prior art. Accordingly, the Examiner is requested to undertake a

thorough and wide-ranging search of the relevant classifications.

No fee is incurred by this Statement.

Respectfully submitted,

  
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Robert E. Bushnell  
Reg. No.: 27,774

1522 "K" Street, N.W., Suite 300  
Washington, D.C. 20005  
Area Code: 202-408-9040

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